

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants:	Yasunori Ito, et al.	CERTIFICATE OF EFS-WEB TRANSMISSION
Serial No.:	10/640,850	I hereby certify that this correspondence is being transmitted electronically through EFS-WEB to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on November 21, 2008.
Filed:	August 13, 2003	Signed: /dn/ Deborah Neill
For:	METHOD OF PRODUCING CERAMIC THERMISTOR CHIPS	
Group Art Unit:	1795	
Confirmation No.:	9131	
Examiner:	H. D. Wilkins III	
Attorney Docket:	MURTP083D1	

EXPRESS ABANDONMENT OF APPLICATION (37 CFR 1.138)

Mail Stop Express Abandonment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The applicant hereby expressly abandons this case

Respectfully submitted,

/kn/

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November 21, 2008
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